

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kyoung-Ju SHIN et al.
Assignee: Samsung Electronics Co., Ltd.
Title: THIN FILM DIODE PANEL AND MANUFACTURING METHOD
OF THE SAME
Application No.: 10/578,028 Filing Date: April 27, 2006
Examiner: Thanh Nhan P. NGUYEN Group Art Unit: 2871
Docket No.: 70105.481 (AB-1883 US) Confirmation No.: 9578

Irvine, California
June 2, 2009

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

**REQUEST FOR CONTINUED EXAMINATION
SUBMISSION**

Dear Sir:

In response to the Final Office Action dated April 1, 2009, Applicants submit the following amendments and remarks in conjunction with a Request for Continued Examination.